

Form PTO-1449 (modified) List of Patents and Publications for Applicant's INFORMATION DISCLOSURE STATEMENT Page 1 of 1	Atty. Docket No. 47163-00018USD1	Serial No. Not Assigned
	Applicant Fujio Kuwako	
	Filing Date: Not Assigned	Group: Not Assigned

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U.S. Patent Documents							
Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date If App.
gm	A01	5,403,672	04/1995	Urasaki et al.	428	607	—
	A02						
	A03						
	A04						
	A05						

Foreign Patent Documents							
Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No
gm	B01	WO97/41713	11/1997	PCT	H05K	3/02	N/A
	B02	Hei 4-3676	1/1992	Japan	H05K	3/46	Abstract
	B03						

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)		
Exam. Init.	Ref. Des.	Citation
gm	C01	"A Flexible Production Laser System for Blind Via Drilling," Anton Kitai and Jim Morrison, Lumonics, Kanata, Ontario Canada; from brochure <i>Proceedings of the Technical Conference Expo '98</i> , 4 pgs.; 1998
	C02	"CO ₂ Laser Drilling Technology for Glass Fabrics Base Copper Clad Laminate," Morio, Gaku, Hidenori Kimbara Nobuyuki Ikeguchi, Yoshihiro Kato, Mitsubishi Gas Chemical Company, Inc., Toyko, Japan; from brochure <i>Proceedings of the Technical Conference Expo '98</i> , 4 pgs.; 1998
	C03	Kestenbaum, Ami, et al., "Laser Drilling Of Microvias In Epoxy-Glass Printed Circuit Boards," <i>IEEE Transactions On Components, Hybrids, and Manufacturing Technology</i> , Volume 13, No. 4, pp. 1055-1062 (December 1990)
	C04	Pargellis, A. N., et al., "Formation of Microvias In Eposy-Glass Composites By Laser Ablation," <i>Optics & Laser Technology</i> , Volume 22, No. 3, pp. 205-207 (June 1990)

EXAMINER: <u>Jeremy Norris</u>	DATE CONSIDERED: <u>4-2-03</u>
<small>EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.</small>	

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